## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Yeo et al. Docket No.: TSM03-0847

Serial No.: 10/826,602 Art Unit: 1795

Filed: April 16, 2004 Examiner: Raymond, Brittany L.

For: Lithography Apparatus for Manufacture of Integrated Circuits

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## AMENDMENT UNDER 37 C.F.R. § 1.116

## Dear Sir:

Applicants respectfully submit the following amendments and remarks in response to Examiner's Office Action dated February 11, 2009, which Action is made final. Applicants respectfully request that these amendments and remarks be entered in pursuant to the provisions of 37 CFR § 1.116, and respectfully request reconsideration of the claims.